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APPLICANTS

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** CONTINUING DATA *****
None ok

** FOREIGN APPLICATIONS *****
None ok

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 10/16/2003

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials	STATE OR COUNTRY CHINA	SHEETS DRAWING 6	TOTAL CLAIMS 11	INDEPENDENT CLAIMS 6
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TITLE
 Method for forming silicon film with changing grain size by thermal process

FILING FEE RECEIVED 1002	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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